

L Number	Hits	Search Text	DB	Time stamp
1		372/45.ccls.	USPAT	2003/11/26 09:43
2		372/45.ccls.	USPAT	2003/11/26 09:43
3		372/45.ccls.	USPAT:	2003/11/26 09:43
	3006	7/2/33.0013.	US-PGPUB;	2003, 11, 20 03.43
	ŀ		EPO; JPO;	
	i		DERWENT	1
_	120631	(nitride or nitrate) and semiconductor	USPAT;	2003/11/25 13:01
=	120031	(interface of interface) and bemiconductor	US-PGPUB;	2003, 21, 23 13.01
	I		EPO; JPO;	
	I		DERWENT	
_	2512	(nitride or nitrate) and semiconductor and	USPAT;	2003/11/25 13:02
	2,14	cladding	US-PGPUB;	,,
	1		EPO; JPO;	
	1		DERWENT	
_	1610	(nitride or nitrate) and semiconductor and	USPAT;	2003/11/25 13:02
	. 1010	cladding and (width or aperture)	US-PGPUB;	
	'	,	EPO; JPO;	
]			DERWENT	[
_	253	(nitride or nitrate) and semiconductor and	USPAT;	2003/11/25 13:02
] ]	233	cladding and (current near3 blocking) and	US-PGPUB;	
		(width or aperture)	EPO; JPO;	
] )			DERWENT	
-	309	(nitride or nitrate) and semiconductor and	USPAT;	2003/11/25 13:14
] ]		cladding and (current near3 blocking)	US-PGPUB;	
] ]			EPO; JPO;	
] ]			DERWENT	[
-	5452	372/43.ccls.	USPAT;	2003/11/25 13:14
] ]	1		US-PGPUB;	,
	i		EPO; JPO;	
			DERWENT	
<b>-</b>	73	372/43.ccls. and ((nitride or nitrate) and	USPAT;	2003/11/25 13:14
	:	cladding)	US-PGPUB;	
]	!		EPO; JPO;	
]			DERWENT	
-	1	372/54.ccls. and (nitride or nitrate)	USPAT;	2003/11/25 13:15
	!		US-PGPUB;	
]	:		EPO; JPO;	
			DERWENT	
] -	719	(	USPAT;	2003/11/25 13:15
	!	nitrate)	US-PGPUB;	·
]	i		EPO; JPO;	
]	l .		DERWENT	
-	310	(current near3 blocking) and (nitride or	USPAT;	2003/11/25 13:15
	:	nitrate) and cladding	US-PGPUB;	
	i		EPO; JPO;	
			DERWENT	I i

L Number	Hits	Search Text	DB	Time stamp
1	2067	372/45.ccls.	USPAT	2003/11/26 09:43
2	2067	372/45.ccls.	USPAT	2003/11/26 09:43
3	3606		USPAT;	2003/11/26 09:43
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	120631	(nitride or nitrate) and semiconductor	USPAT;	2003/11/25 13:01
			US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	2512	(nitride or nitrate) and semiconductor and	USPAT;	2003/11/25 13:02
		cladding	US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	1610	(nitride or nitrate) and semiconductor and	USPAT;	2003/11/25 13:02
		cladding and (width or aperture)	US-PGPUB;	
			EPO; JPO;	
			DERWENT	
-	253	(nitride or nitrate) and semiconductor and	USPAT;	2003/11/25 13:02
		cladding and (current near3 blocking) and	US-PGPUB;	
		(width or aperture)	EPO; JPO;	
			DERWENT	
-	309	, <del>, , , , , , , , , , , , , , , , , , </del>	USPAT;	2003/11/25 13:14
		cladding and (current near3 blocking)	US-PGPUB;	
			EPO; JPO;	
	5.455	250/421-	DERWENT	2003/11/25 13:14
_	5452	372/43.ccls.	USPAT;	2003/11/25 13:14
			US-PGPUB;	
			EPO; JPO; DERWENT	
	73	372/43.ccls. and ((nitride or nitrate) and	USPAT;	2003/11/25 13:14
_	/3	cladding)	US-PGPUB;	2003/11/23 13.14
		cradding,	EPO; JPO;	
			DERWENT	
_	1	372/54.ccls. and (nitride or nitrate)	USPAT;	2003/11/25 13:15
	_	J/2/JI. Octor and (meetad of meetad)	US-PGPUB;	1000, 11, 10 10:10
			EPO; JPO;	
			DERWENT	
-	719	(current near3 blocking) and (nitride or	USPAT;	2003/11/25 13:15
		nitrate)	US-PGPUB;	
		·	EPO; JPO;	
			DERWENT	
-	310	(current near3 blocking) and (nitride or	USPAT;	2003/11/25 13:15
		nitrate) and cladding	US-PGPUB;	
			EPO; JPO;	
			DERWENT	